Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/697,469	ABE, SHIGEO
Examiner	Art Unit
Y J Han	2838

SEARCHED					
Class	Subclass	Date	Examiner		
363	22				
	23				
	40				
	56.02				
	79		_		
-	98		•		
	132	3/05	812		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
363	22				
	98				
	132	3/05	97		

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